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Generation and Manipulation of Superoscillatory Hotspots Using Virtual Fourier Filtering and CTF Shaping

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Superoscillation is a technique that is used to produce a spot of light (known as 'hotspot') which is smaller than the conventional diffraction limit of a lens and even smaller than the optical wavelength. Over the past few years, several techniques have been realized for the generation of the superoscillatory hotspot. In this article, for the first time to the best of our knowledge, we propose a novel and a more efficient technique for producing superoscillation in microscopic imaging by shaping the Coherent Transfer Function (CTF) of a lens via virtual Fourier filtering followed by a phase retrieval algorithm. We design and realize a phase mask which when placed at the pupil plane of a diffraction-limited lens produces a superoscillatory hotspot with sidelobes properly matched to the field of view (FOV) required in microscopic imaging applications, i.e. hotspot always coexists with huge intense rings known as 'sidebands' close to it and hence limiting the FOV. Our technique is also capable of extending the FOV with minimal loss in resolution of the hotspot generated and considerable ratio between the intensity of the hotspot to that of the side lobes while optimizing the obtainable FOV to the requirement of microscopy.

Imaging and microscopy have undoubtedly become an important tool in almost all fields of today's technological world to see, visualize and analyze objects that are otherwise not seen by our naked eyes. Unfortunately, the lenses used in the optical microscope have a limit to the smallest resolvable feature. Before we talk about this limitation, it's worth mentioning, how a lens forms an image of an object. An object scatters light at all angles due to diffraction. As the size of the object decreases the angle of diffracted light which carries the information about the object increases. So, while imaging smaller objects, conventional lens (due to limited aperture size) cannot collect all these light waves diffracted at a higher angle. Hence resulting in poor resolution of the image of the object. Ernst Abbe, in 1873, demonstrated that there is a limit to the resolution that a conventional lens can achieve and it is dependent on the wavelength of light, λ , and the numerical aperture (NA) of the objective lens to be: $d = 0.61\lambda/NA$ ¹. A microscope working in the air medium can have a max value of NA as 1. Hence the conventional diffraction limit is $\sim 0.61\lambda$. However, it is also possible to use immersion media to have NA greater than 1 because of its higher refractive index^{2,3}.

Perhaps this fundamental limit has encouraged many researchers to come up with several techniques over the years to greatly enhance the resolution of optical microscope between tens and hundreds of nanometers. For instance, scanning near-field optical microscopy (SNOM) developed in 1984^{4,5}, capture the evanescent near field waves close to the object. There have also been numerous other techniques utilizing the evanescent waves⁶⁻¹⁰. But these techniques are not suitable for thick samples like a biological cell because then it is required for the probe to be within tens of nanometers from the sample which limited its practicability. Other well-known superresolution techniques are: Structured illumination microscopy¹¹ (SIM), Stimulated emission depletion (STED) by use of a doughnut beam¹² and fluorescence localization microscopy¹³. The SIM techniques help in retrieving the lost higher spatial frequency content in an image by shifting the frequency content using spatially modulated light followed by a post-processing step to retrieve the high-resolution image. However, the improvement in resolution

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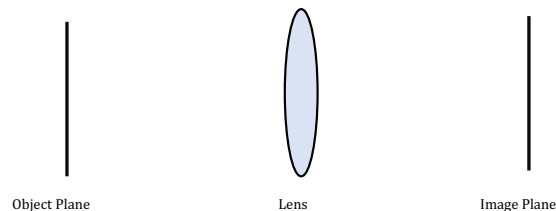


Figure 1. Typical coherent imaging system.

is only about twice that of the traditional microscopes. Additionally, the post-processing steps are complicated and time-consuming. Non-linear methods like STED and fluorescence localization microscopy, however, require either fluorescence labeling or post-processing to achieve superresolution. Recently, the concept of superoscillation has emerged significantly in the context of far-field, label-free and non-contact superresolution imaging.

Superoscillation is a mathematical concept in which a band-limited function is capable of having a local component that can oscillate faster than its fastest Fourier component^{14,15}. Superoscillation in optics originated from the work of Torraldo di Francia in which he applied the concepts of super-directive antennas to an optical imaging system to see beyond the diffraction limit¹⁶. The idea of superoscillation was conceived and applied to many physical systems by Berry¹⁷. His works were mainly based on the work of Aharonov *et al.* on weak measurements in quantum systems¹⁸. Method for creation of optical superoscillation using a complex diffraction grating was proposed by Berry and Popescu¹⁹. Huang *et al.*²⁰, demonstrated experimentally, for the first time, optical superoscillations by diffraction from a quasi-periodic array of nanoholes. Using superoscillatory techniques we can achieve a small spot which will be called from now as ‘hotspot’ which is less than the diffraction limit, while this is obtained at the expense of energy. In terms of optical superoscillations, a hotspot will always be accompanied by high-intensity side lobes which are higher in energy than the hotspot in the center.

In 2012, Rogers *et al.* developed a new superoscillatory microscope. They developed and fabricated a binary phase mask consisting of concentric rings that are based on binary particle swarm algorithm²¹. Creation of super-oscillating (SO) beams with sub-diffraction limited features have been developed by modulating the lens’ pupil^{21,22} and by superposition of Bessel beams^{23–25}. A super oscillatory function could also be constructed using a complete set of prolate spheroidal wavefunctions (PSWFs)²⁶. The concept of design of annular pupil phase filters for the generation of superoscillation was proposed by Cagigal *et al.* in 2004²⁷. In 2017 Singh *et al.* developed a method using Spatial Light Modulator (SLM) for shaping the sub-diffraction hotspot obtained and using it to trap a single nano-particle²⁸. In 2018, Rogers *et al.* with the use of PSWFs achieved simultaneously optimization of spot size and Field of view²⁹. In 2019, Shapira *et al.* investigated methods to produce multi-lobe optical superoscillating beams, with nearly constant intensity and constant local frequency and successfully tested in structured illumination microscopy³⁰.

Though the techniques described above are undoubtedly powerful in producing superoscillatory hotspots, most of them use strong mathematical calculations for the formulation of the phase mask that is needed for the creation of the hotspot or they use some sort of optimization algorithm to attain it. In our research, we propose a novel technique in which we design a phase mask which when applied to a lens can produce a superoscillatory spot. The main advantage of our technique is that we use a simple Coherent Transfer Function (CTF) shaping computed digitally in a computer by using virtual Fourier filtering without the need of using any complex mathematical functions or calculations. We also show that we are capable of tailoring different hotspot size with varying FOV. Specifically, those that match well the microscopy applications in which imaging of cells having a FOV being around 10–15 microns. We show through simulation, that indeed it is possible to go beyond the classical diffraction limit using our technique. As proof of our concept, we experimentally apply our technique on a digital lens that is being realized with a spatial light modulator (SLM) having $NA = 0.0075$ at $\lambda = 543 \text{ nm}$.

Materials and Methods

Principle. Let us consider a coherent imaging system as shown in Figure 1. This can be described as a convolution operation between the coherent impulse response of the system and the field at the object plane described by Eq. 1

$$U_i = h(x, y) \otimes U_o \quad (1)$$

where U_o and U_i are the field at object and image plane respectively, h is the coherent impulse response of the imaging system, \otimes is the convolution operator and x, y are the coordinates of the image plane. Let H be the Fourier transform of h . The impulse response h in our case is the point spread function of the lens (*psf*). In the frequency domain the corresponding spectra of Eq. 1 can be written as

$$G_i(u, v) = H(u, v) G_o(u, v) \quad (2)$$

where H is the coherent image transfer function (CTF), u, v are the frequency coordinates. H can be described as:

$$H(u, v) = P(-\lambda z_f u, -\lambda z_f v) \quad (3)$$

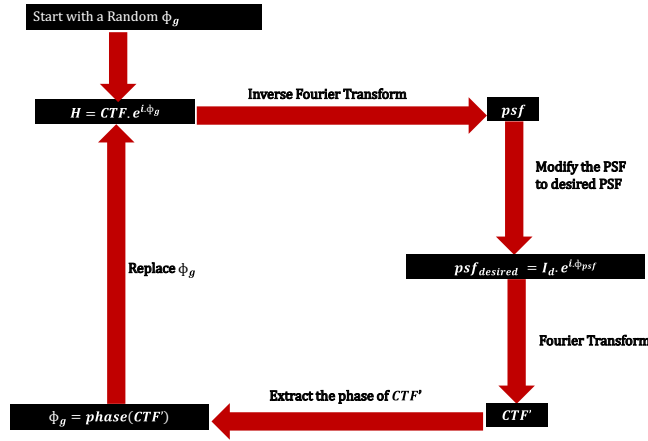


Figure 2. Steps involved in regular CTF shaping.

where P is the pupil of the system, λ wavelength of the light used and z_f the focal length of the imaging system. For a lens, the pupil function is a circular aperture given by

$$P = \text{circ}\left(\sqrt{(x^2 + y^2)/w}\right) \tag{4}$$

where w is the radius of the aperture of the lens. From Eqs. 3 and 4 we have an expression for H as:

$$H = \text{circ}\left(\sqrt{(u^2 + v^2)/f_0}\right) \tag{5}$$

where f_0 is the cut off frequency of the CTF given by:

$$f_0 = \frac{w}{\lambda z_f} \tag{6}$$

where z_f is the focal length of the lens.

Phase retrieval techniques like the Gerchberg-Saxton (GS) algorithm deal with the problem of obtaining the phase of a light field by just knowing the modulus of its Fourier transform³¹. Hence using this technique, it is possible to engineer the psf of a lens³²⁻³⁴. In our technique, we use a modified GS algorithm to engineer the psf of the lens to obtain a hotspot. Before we discuss the modification, it's worth mentioning the existing GS algorithm for psf shaping. The basic idea of psf shaping is to apply a phase mask in the lens pupil plane, such that the psf of the lens is shaped to the desired intensity profile. The advantage of this technique is that it is done digitally on a computer. Figure 2 sketches the steps involved in the G.S algorithm to obtain the phase mask that can be used to shape the psf .

The algorithm starts with an assumption of a random phase mask with phase Φ_g , varying from 0 to 2π phase. This phase mask is multiplied with the pupil function of the lens, i.e with the CTF to obtain a new CTF denoted as

$$H_{new} = CTF \cdot e^{i\Phi_g} \tag{7}$$

We then proceed to take the inverse Fourier transform of H_{new} , which would yield the psf of the system corresponding to H_{new} in the psf plane. In the following step, we preserve the phase of the psf and set the amplitude as our desired amplitude pattern. We then perform Fourier transform on the $psf_{desired}$ to yield CTF' in the CTF plane. In the next step value of Φ_g is updated by extracting the phase from CTF' . This is one iteration. This is continued till there is a convergence of the psf to the desired psf . The result is a phase mask with a phase Φ_g which when placed at the pupil plane of the lens will result in a shaped psf . This is a very powerful technique to shape the psf . The requirement is to know the desired amplitude pattern beforehand. It is possible to construct a hotspot amplitude pattern mathematically and set it as desired psf amplitude to obtain the phase mask. However, the mathematical construction of such hotspots already yields the corresponding phase masks that produce such spots. Hence, there is no need to do such an iterative algorithm for obtaining the same. Also, mathematically it is hard to construct such hotspots.

Using our novel technique, we show that indeed without the prior knowledge of such mathematically formulated hotspot amplitudes, it is possible to create a phase mask that can produce hotspots with a small modification to the existing GS algorithm. Figure 3 explains the modified G.S Algorithm for shaping the psf to a superoscillatory hotspot.

The modification is shown in the green dotted box, where instead of setting the desired amplitude pattern to the desired psf , we perform a virtual Fourier filtering of the psf using a filter mask. The filter mask has a circular region with a radius r_1 , and an annular region with an inner radius r_2 and outer radius r_3 . The criteria for the

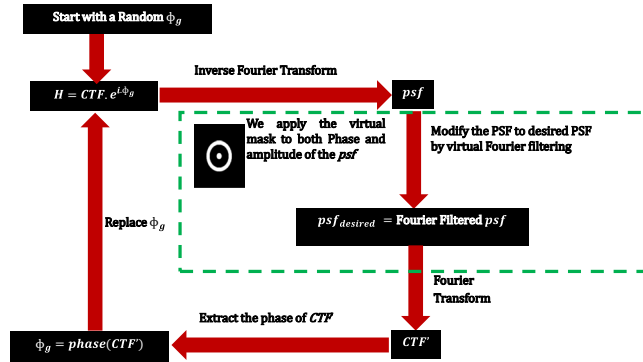


Figure 3. Steps involved in the modified Algorithm for CTF shaping.

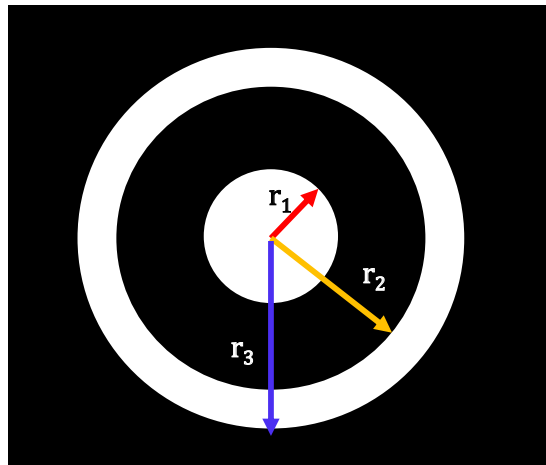


Figure 4. Virtual Fourier Filter Mask.

selection of these radii will be discussed later in the simulation section. The mask takes the following functional value: (please refer to Figure 4)

$$Mask = \begin{cases} 1, & 0 \leq r \leq r_1 \text{ and } r_3 \geq r \geq r_2 \\ 0, & \text{else} \end{cases} \tag{8}$$

In the modified step, we multiply the virtual mask to the extracted phase of the *psf* (denoted by θ) and set amplitude as that of the mask (m). Hence the filtered *psf* can be written as

$$psf_{desired} = m \cdot e^{i \cdot m \cdot \theta} \tag{9}$$

The remaining steps are the same. After several iterations, the *psf* will converge to a hotspot depending on the right choice of the filter mask. In the following section, we show how it can be done through MATLAB simulation.

Simulation. In the simulation, we show results for 3 different wavelengths ($\lambda = 532 \text{ nm}$, 460 nm and 632 nm) for a lens with the same *NA* (equals 1). The initial step in the simulation is to set the pixel size of the *psf* plane ($dx = 6.65 \text{ nm}$). The physical length, L of the *psf* plane is given by

$$L = M \cdot dx \tag{10}$$

where M is the number of pixels in the x-direction. We have set $M = 1024$ pixels. Now we can formulate the *CTF* plane based on the *psf* plane. They both are related by a Fourier transform. Hence the pixel size of the *CTF* plane is given by

$$df = \frac{1}{L} \tag{11}$$

We then define the lens aperture radius w and the focal length z_f . Based on Eq. 6, we can calculate the cut off frequency in the *CTF* plane. Hence, we can define the *CTF* of the lens based on Eq. 5. It is a circle of radius f_0 . The

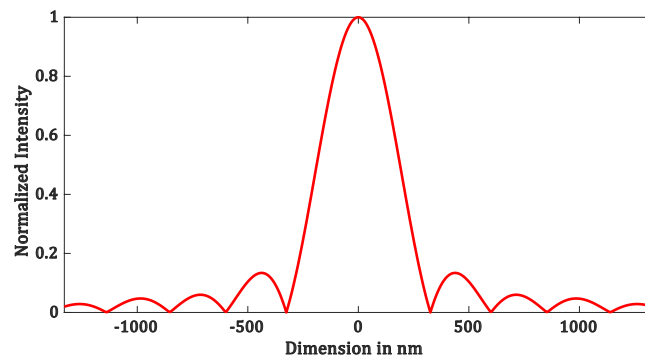


Figure 5. Amplitude plot of PSF of the simulated lens.

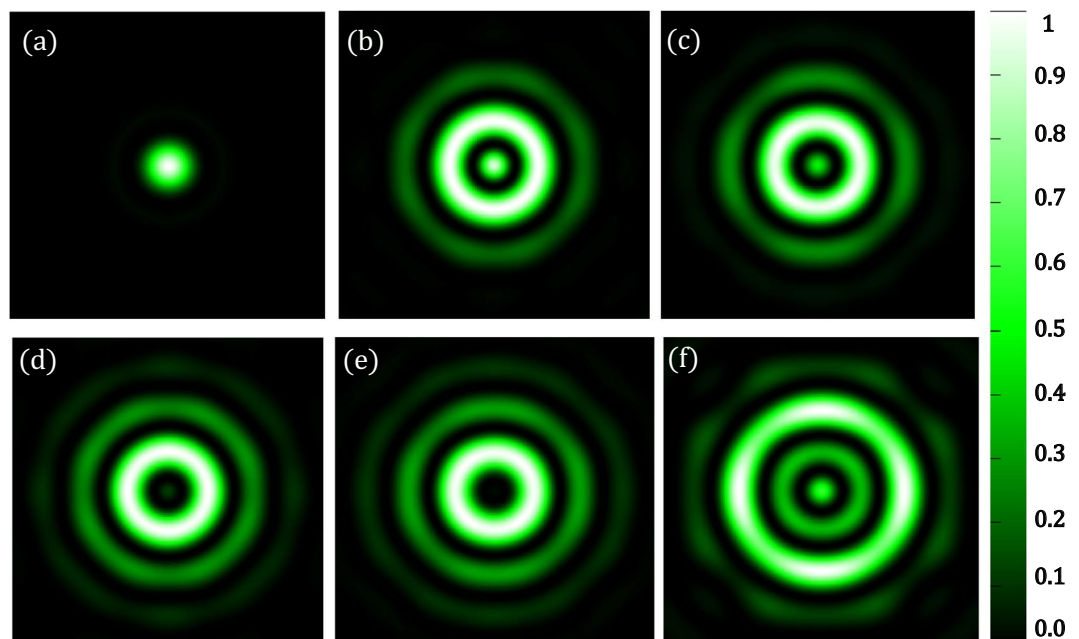


Figure 6. Simulation results for $\lambda = 532 \text{ nm}$, $NA = 1$ (a) Diffraction-limited spot of size $324.5 \pm 6.65 \text{ nm}$. Superoscillatory hotspot of sizes (b) $179.2 \pm 6.65 \text{ nm}$ (c) $153.1 \pm 6.65 \text{ nm}$ (d) $113.2 \pm 6.65 \text{ nm}$. (e) $86.6 \pm 6.65 \text{ nm}$ (f) Superoscillatory hotspot of size $166.4 \pm 6.65 \text{ nm}$ with an extended FOV of $1123.7 \pm 6.65 \text{ nm}$.

inverse Fourier transform of *CTF* yields the diffraction-limited *psf*. Figure 5 shows the amplitude plot of the diffraction-limited *psf* for ($\lambda = 532 \text{ nm}$, $NA = 1$, $dx = 6.65 \text{ nm}$).

The radius of the Airy disk is given by $(1.22\lambda z_f/D)$, where D is the aperture of the lens. Hence the total width of the airy disk is given by $(d = 1.22\lambda/NA)$. In the case of $\lambda = 532 \text{ nm}$, $NA = 1$, we have a diffraction-limited spot with $d \sim 649 \text{ nm}$.

Now we can move forward towards designing the virtual filter mask to be applied on the *psf*. The mask is a binary filter mask as described by Eq. 8. We have three parameters r_1 , r_2 and r_3 . Value of r_2 and r_3 can be set at the beginning. The choice of r_2 and r_3 is made based on the amplitude plot shown in Figure 5. The value of r_2 and r_3 is the radius where the *psf* amplitude first goes to zeros and then increases to maximum respectively. For $\lambda = 532 \text{ nm}$, we have $r_2 = 325.8 \text{ nm}$ and $r_3 = 438.9 \text{ nm}$. Once we set these two parameters, the selection of r_1 is crucial in the formation of hotspots. r_1 can take any values between 0 to 325.8 nm . Pixel wise there are 49 values for r_1 . We tried several masks with all possible values of r_1 and came to the following conclusions. We found that there is an upper and lower limit of r_1 that would help us achieve the hotspot after *CTF* shaping. Value of r_1 should be such that the ratio between r_1 and r_2 should be greater than 0.25. This sets the lower limit for r_1 . The upper limit for r_1 is such that it r_1 should be less than the *FWHM* of the diffraction-limited amplitude plot. Once we design the mask, for each mask we perform the steps mentioned in Figure 3.

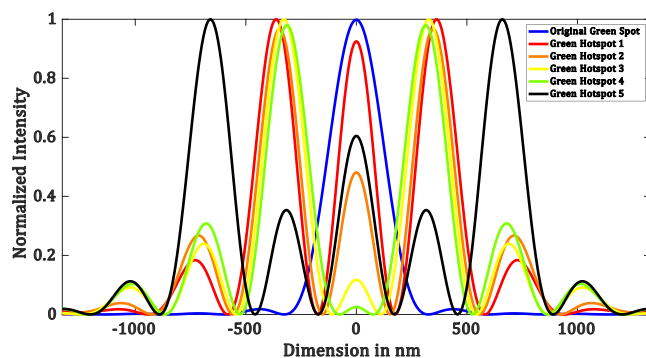


Figure 7. Intensity profile plots of the simulated results in Figure 6. Blue plot refers to the intensity profile plot of Figure 6(a), red plot refers to the intensity profile plot of Figure 6(b), black plot refers to the intensity profile plot of Figure 6(f), orange plot refers to the intensity profile plot of Figure 6(c), yellow plot refers to the intensity profile plot of Figure 6(d) and green plot refers to the intensity profile plot of Figure 6(e).

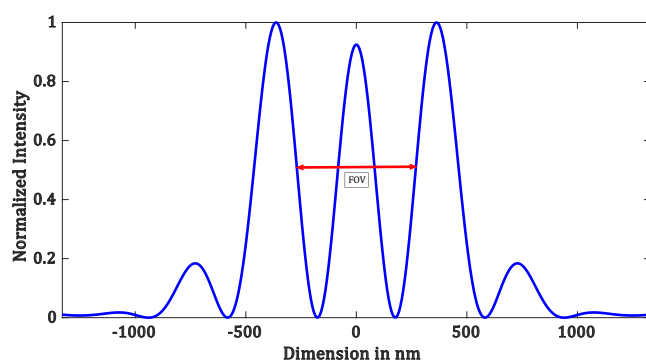


Figure 8. FOV measurement.

MASK #	r_1 (nm)	r_2 (nm)	r_3 (nm)
1	86.45	325.8	438.9
2	133	325.8	438.9
3	166.25	325.8	438.9
4	186.2	325.8	438.9
5	79.8	598.5	718.2

Table 1. Fourier filter mask's parameters for $\lambda = 532$ nm, $NA = 1$.

Each mask takes about 100 iterations to yield a hotspot. In Fig. 6(a–e), we show the diffraction-limited spot as well as a few such hotspots created using our simulation technique for $\lambda = 532$ nm. Figure 7 shows the corresponding intensity profiles. The parameters of the masks are shown in Table 1. We have seen that, for the creation of hotspot r_1 takes values such that $86.45 \leq r_1 < 192.85$. It is interesting to note that the region between r_1 and r_2 , where the mask is zeros. This region is related to the field of view (FOV) of the superoscillatory spot. FOV is measured between the two points on the side lobes as shown in Figure 8. It forces the algorithm to set the phase and intensity of the *psf* in this region to be zero. So larger the zero region between r_1 and r_2 is, the smaller will be the hotspot being produced. Hence, we have a tenability with regard to the size of the hotspot obtained. Also, by forcing the field at those points to be zero, the intensity is redistributed such that it forms a superoscillatory spot.

As previously mentioned, the hotspots are always accompanied by huge intense sidelobes which limit the FOV and hence its applicability. Using the proposed technique, we could also increase the FOV by designing another filter mask such that we still obtain a hotspot with sufficiently good resolution below the diffraction limit and at the same time have an increased FOV.

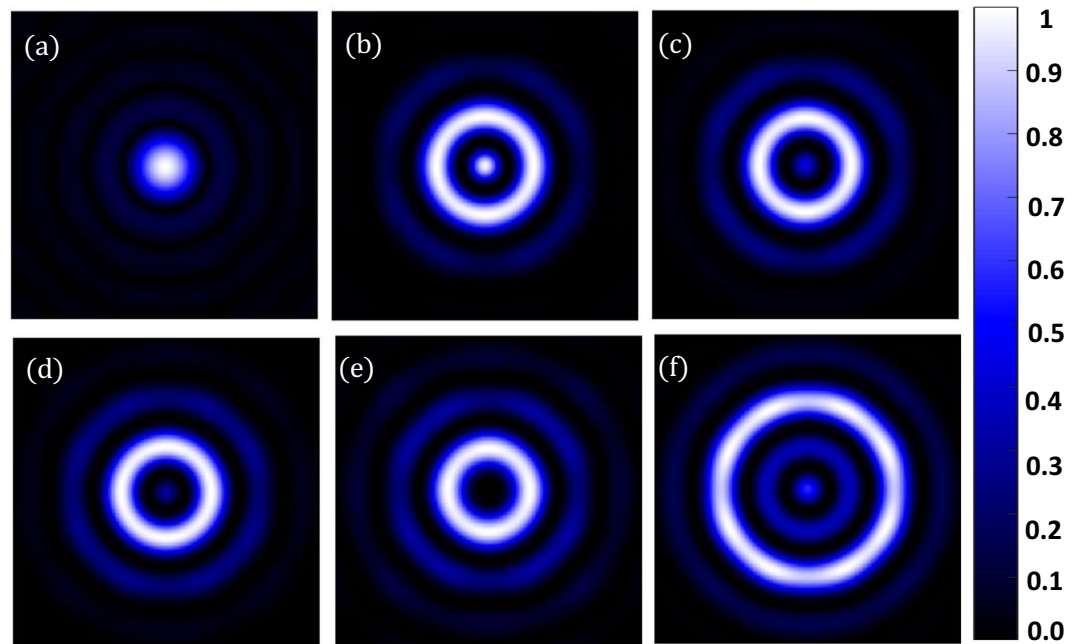


Figure 9. Simulation results for $\lambda = 460 \text{ nm}$, $NA = 1$ (a) Diffraction-limited spot of size $280.6 \pm 6 \text{ nm}$. Superoscillatory hotspot of sizes (b) $166.1 \pm 6.65 \text{ nm}$ (c) $139.5 \pm 6.65 \text{ nm}$ (d) $112.9 \pm 6.65 \text{ nm}$. (e) $46.4 \pm 6.65 \text{ nm}$ (f) Superoscillatory hotspot of size $126.2 \pm 6.65 \text{ nm}$ with an extended FOV of $964.1 \pm 6.65 \text{ nm}$.

Mask #	Figure #	Hotspot FWHM (nm)	FOV (nm)
1	6 (b)	179.2 ± 6.65	738.5 ± 6.65
2	6 (c)	153.1 ± 6.65	498.7 ± 6.65
3	6 (d)	113.2 ± 6.65	458.5 ± 6.65
4	6 (d)	86.6 ± 6.65	432.1 ± 6.65
5	6 (f)	166.4 ± 6.65	1123.7 ± 6.65

Table 2. Simulation Result Analysis with respect to Hotspot size and FOV to the mask used for $\lambda = 532 \text{ nm}$, $NA = 1$.

This is because our filter design is such that between the hotspot and the main side lobe there is a minor side lobe whose peak intensity is smaller than the hotspot. We will now describe how to choose the value of the radii of such a mask that would produce a hotspot with increased FOV.

Referring to Figure 5, we will set the value of r_2 and r_3 based on the second minor sidelobes. Value of $r_2 = 598.5 \text{ nm}$, where the amplitude drops to zero and $r_3 = 718.2 \text{ nm}$, where the amplitude then goes to a maximum. Now choosing of r_1 will yield us a hotspot. We found that a hotspot is obtained when the value of r_1 is such that the ratio between r_1 and the point where the amplitude of the *psf* first drops to zeros (i.e. 325.8 nm) is less than 0.25, which means it can take values between $0 < r_1 \leq 79.8$. But not all values yield increased FOV. The upper limit value will yield a hotspot with increased FOV. As the value of r_1 is decreased from the upper limit we see that there would be an increase in the intensity of the minor sideband with respect to the hotspot which will destroy the FOV of the hotspot. We simulated the increased FOV for the case in which r_1 is set to 79.8 nm and yields an increased FOV. Figure 6(f) shows the hotspot with increased FOV of $1123.7 \pm 6.65 \text{ nm}$ with a hotspot size of $166.4 \pm 6.65 \text{ nm}$ very well below the diffraction limit. Now we can have an analysis of the intensity profile plots in Figure 7. Blue plot refers to the diffraction-limited spot size of $324 \pm 6.65 \text{ nm}$. Table 2 consolidates the obtained hotspot sizes and the corresponding FOVs. We obtain a range of hotspot sizes from 86.6 – 179.2 nm . There is an increase in FOV from $498.7 \pm 6.65 \text{ nm}$ to 1123.7 ± 6.65 while keeping the increase in hotspot size considerably less from 153.1 nm to 166.4 nm . (Refer Figure 6(c,f)).

Simulation is done for other wavelengths as well ($\lambda = 460 \text{ nm}$ and 632 nm). We have kept the NA to be the same as the previous one. Figures 9–12 shows the results corresponding to these wavelengths. The mask parameters corresponding to each wavelength are tabulated in the supplementary material (Tables S1 and S2). In the supplementary material, we also show that our method can be generalized to any wavelength and NA . And we have seen that the criteria of selection of the mask parameters remain unchanged with wavelength and NA .

Using our simulation (for $\lambda = 532 \text{ nm}$), we obtained a phase mask with 24×24 pixels with a pixel size that corresponds to the CTF plane given by:

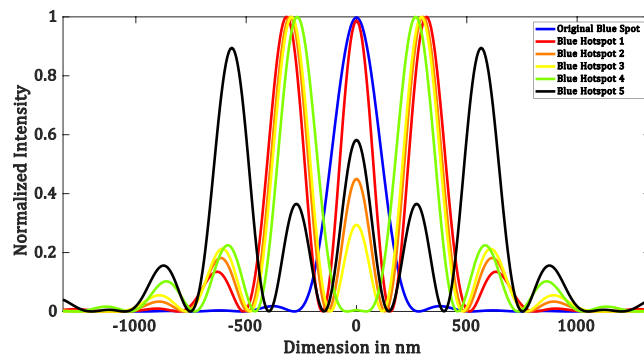


Figure 10. Intensity profile plots of the simulated results in Figure 9. Blue plot refers to the intensity profile plot of Figure 9(a), red plot refers to the intensity profile plot of Figure 9(b), black plot refers to the intensity profile plot of Figure 9(f), orange plot refers to the intensity profile plot of Figure 9(c), yellow plot refers to the intensity profile plot of Figure 9(d) and green plot refers to the intensity profile plot of Figure 9(e).

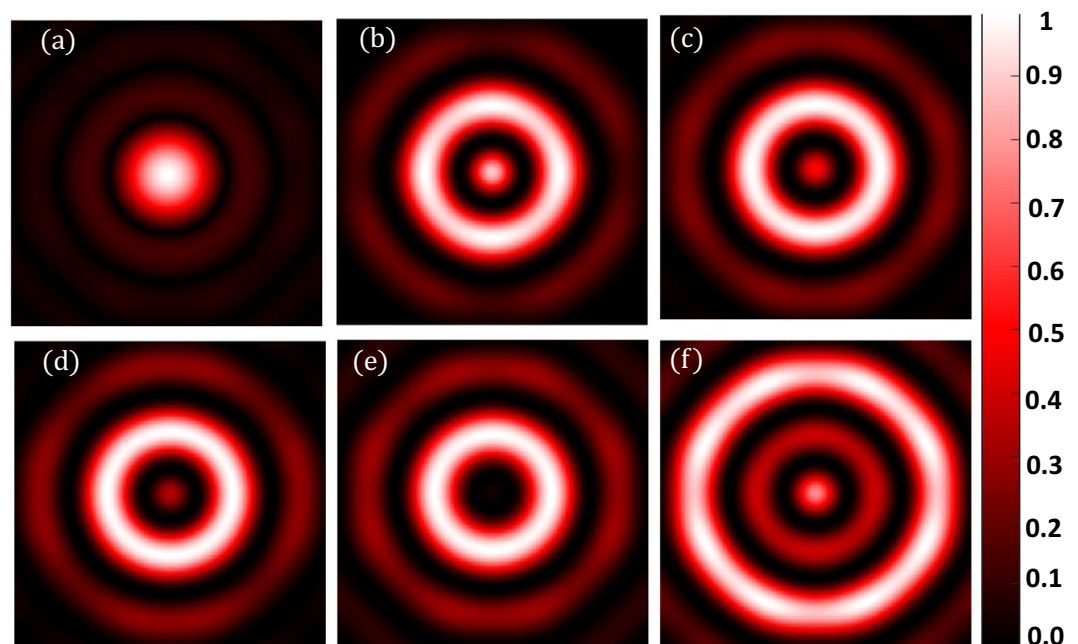


Figure 11. Simulation results for $\lambda = 632 \text{ nm}$, $NA = 1$. (a) Diffraction-limited spot of size $3 \pm 6 \text{ nm}$. Superoscillatory hotspot of sizes (b) $192.7 \pm 6.65 \text{ nm}$ (c) $179.7 \pm 6.65 \text{ nm}$ (d) $166.5 \pm 6.65 \text{ nm}$. (e) $113.2 \pm 6.65 \text{ nm}$ (f) Superoscillatory hotspot of size $206.3 \pm 6.65 \text{ nm}$ with an extended FOV of $1336 \pm 6.65 \text{ nm}$.

$$\delta = \lambda \cdot z_f \cdot df \quad (12)$$

where λ , z_f , df is the wavelength of the light, focal length of the lens and pixel size of the CTF plane respectively. In our case $\delta = 335 \mu\text{m}$. But since the physical dimension of the lens that we chose is 8.3 mm , which is equal to the pupil size, we will need to re-size the obtained phase mask to match the physical size of the pupil of the lens. In real experiments, it can be realized by applying the synthesized mask on the lens aperture using an SLM. The 24×24 pixels mask can be resized according to the pixel size of the SLM. The typical pixel size of an SLM is $\sim 8 \mu\text{m}$. For instance, by merging 45 pixels together we can convert 24×24 pixels to 1080×1080 pixels which is the typical resolution of our SLM. This is done to reduce the computational load. Else we would need to compute the phase mask for 1080×1080 pixels of the SLM which can be done only by zero-padding the 1080×1080 pixels sufficiently to a higher number, which eventually will increase the computational load.

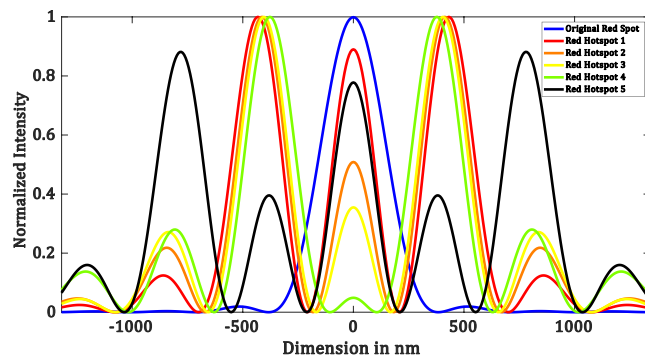


Figure 12. Intensity profile plots of the simulated results in Figure 11. Blue plot refers to the intensity profile plot of Figure 11(a), red plot refers to the intensity profile plot of Figure 11(b), the black plot refers to the intensity profile plot of Figure 11(f), the orange plot refers to the intensity profile plot of Figure 11(c), the yellow plot refers to the intensity profile plot of Figure 11(d) and green plot refers to the intensity profile plot of Figure 11(e).

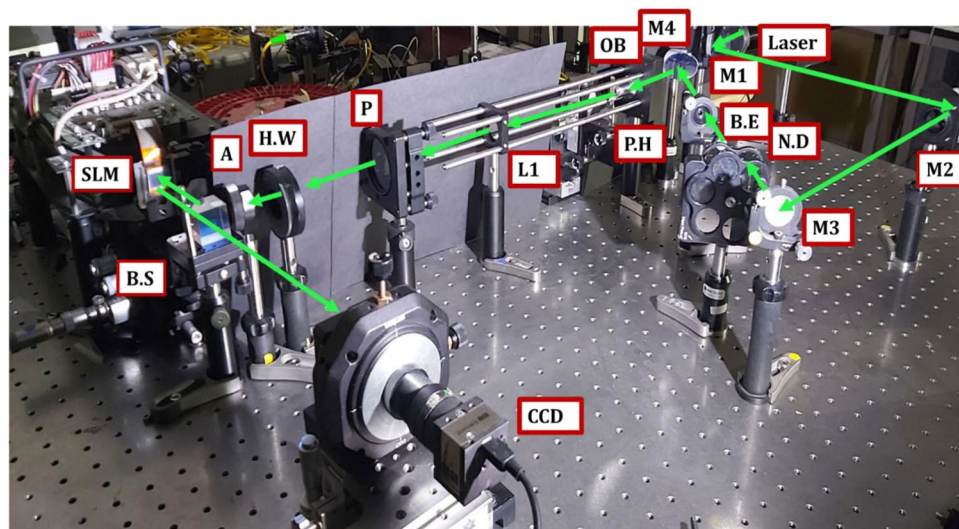


Figure 13. Experimental setup for producing super oscillatory hotspots. 543 nm laser passes through a variable Neutral Density filter N.D reflected from mirrors M1, M2, and M3. It is then expanded using a beam expander B.E. and is reflected using mirror M4 to the back aperture of a microscope objective OB (25X). It is then pinhole filtered by P.H of size $15\ \mu\text{m}$ and collimated using lens L1 of focal length 200 mm. Polarizer P polarizes the beam, halfwave plate H.W sets the polarization to the working polarization of the phase-only SLM. Aperture A sets the size of the illuminating beam on SLM. Beam splitter B.S reflects the beam to illuminate the SLM and transmits the phase-modulated light towards the CCD.

Results and Discussion

In order to show the proof of concept experimentally, we programmed a lens phase function in a computer-generated hologram and displayed it on our Spatial Light Modulator (SLM, HoloEye, 1080×1920 pixels, $8\ \mu\text{m}$ pixel size) such that it produces a diffraction-limited spot corresponding to a lens of 400 mm focal length at a distance of 400 mm from the SLM in +1 or -1 diffraction order. Figure 13 shows the experimental setup we used. We used a spatially filtered collimated and well-expanded laser beam (543 nm Coherent Laser) to illuminate the SLM. We illuminated only a circular region of the total pixels with a diameter of 750 pixels. Hence the lens function on the SLM is equivalent to a lens of $\text{NA} = 0.0075$. The theoretical FWHM of the Airy disk diameter of such a lens is given by $(0.61\lambda/\text{NA}) = 44.16\ \mu\text{m}$. The focal spot was captured directly on a CCD sensor (Edmund Optics Camera 1920×2560 pixels) with a pixel size of $2.2\ \mu\text{m}$. Figure 14(a) shows the diffraction-limited hotspot obtained when we applied the hologram that corresponds to the lens function on the SLM. The spot size is about $57.6 \pm 2.2\ \mu\text{m}$. SLM plane deviations and noise resulted in a larger spot than expected. Despite these aberrations, we were able to obtain the hotspot and its dimension is close to the one designed in simulations.

The simulation was performed on a lens that is equivalent to an NA of 0.0075. We have already discussed the criteria for the selection of the virtual mask that we use to perform the Fourier filtering. We have used 1024×1024 pixels in simulation with a pixel size of the *psf* plane as $1\ \mu\text{m}$. We have used two masks for CTF shaping, mask 1 and mask 2 (Figure 14(a,b)) that yield a phase mask that produces superoscillatory hotspot of FWHM

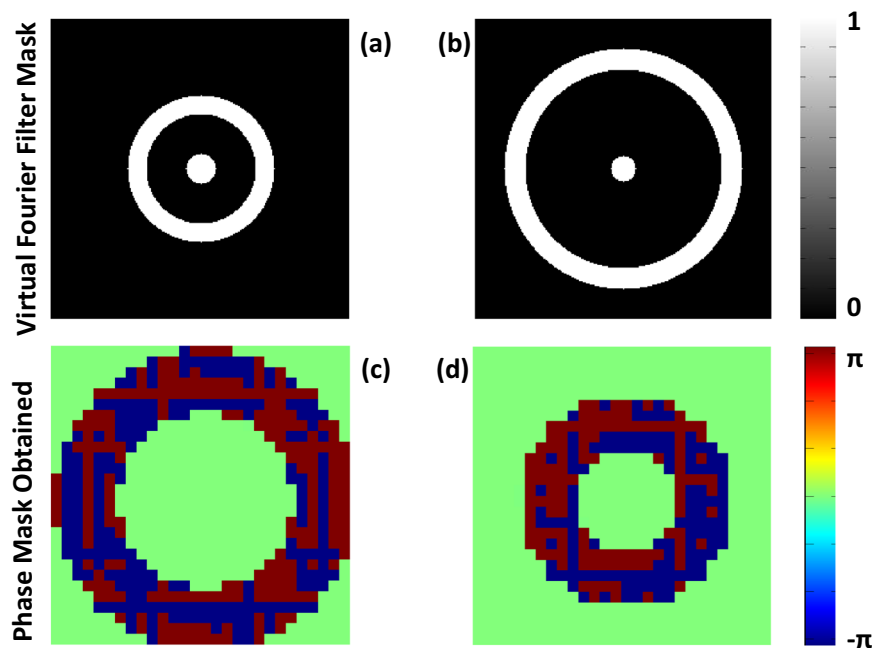


Figure 14. (a) Virtual Fourier filter mask 1. (b) Virtual Fourier filter mask 2. (c,d) The obtained phase mask corresponding to mask 1 and mask 2 respectively after the CTF shaping. The phase mask is resized to fit the SLM pixel size of $8\ \mu\text{m}$.

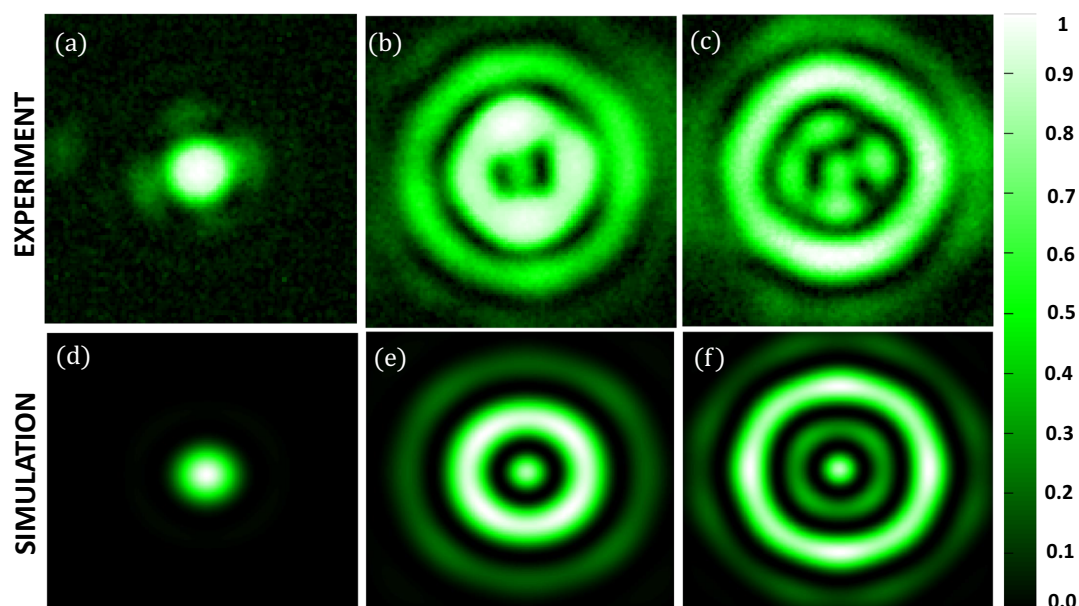


Figure 15. (a–c) Show experimental data and (d–f) show simulated data. (a) Diffraction limited spot of the size of $\sim 57.36 \pm 2.2\ \mu\text{m}$. (b) Hotspot of size $\sim 25.6 \pm 0.2\ \mu\text{m}$. (c) Hotspot of size $\sim 26.6 \pm 0.2\ \mu\text{m}$. (d) Simulated Diffraction-limited spot of size $27.5 \pm 1\ \mu\text{m}$. (e) Hotspot of size $25 \pm 1\ \mu\text{m}$ (f) Hotspot of size $25 \pm 1\ \mu\text{m}$ with increased FOV.

$= 23 \pm 1\ \mu\text{m}$ and $25 \pm 1\ \mu\text{m}$ respectively. Figure 14(c,d) show the phase mask obtained after CTF shaping. The obtained phase mask is encoded in a computer-generated off-axis hologram and is applied on the SLM which already has a hologram with the lens function. So, it will be equivalent to the case in which we are placing a phase mask in the pupil plane of the lens. Mask 1 has parameters of $r_1 = 12\ \mu\text{m}$, $r_2 = 44\ \mu\text{m}$ and $r_3 = 59\ \mu\text{m}$. Mask 2 has parameters of $r_1 = 10\ \mu\text{m}$, $r_2 = 80\ \mu\text{m}$ and $r_3 = 97\ \mu\text{m}$.

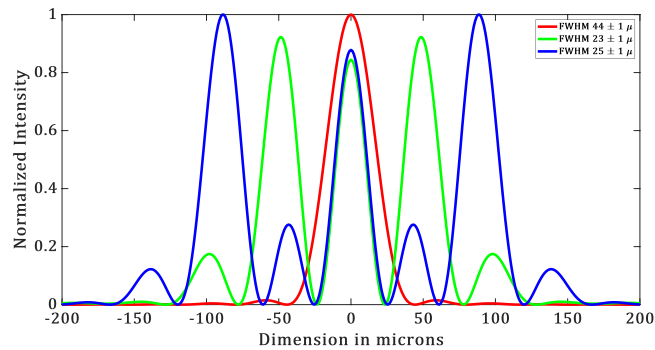


Figure 16. Intensity profile plots of the simulated images in Fig. 15(d–f).

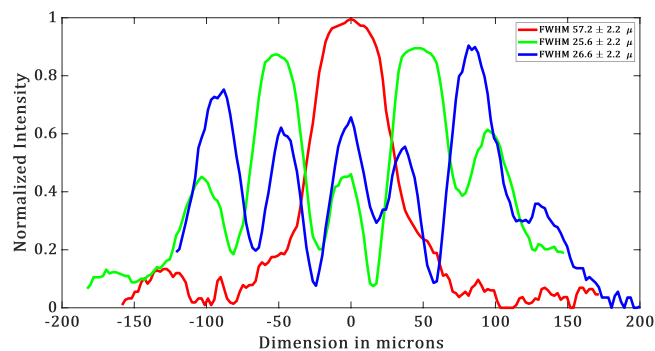


Figure 17. Intensity profile plots of the experimental images in Figure 15(a–c).

The experimental results are shown in Figure 15(a–c) and the corresponding simulated results are shown in Figure 15(d–f). From the intensity profile plots (see Figure 16 and 17) of the images in Figure 15, we see that the simulated results are well in agreement with the experimental results. For simulated hotspot of size $23 \pm 1 \mu\text{m}$, we get $\sim 25.6 \pm 2.2 \mu\text{m}$ in the experiment (see Figure 15(b)). In this case, we have a FOV of $66 \mu\text{m}$ in the experiment versus $71 \mu\text{m}$ in simulation. The intensity ratio between the maximum of the hotspot to that of the side lobes is equal to 0.52 in the experiment whereas in the simulation it is about 0.91. This deviation is probably due to the non-uniformity in the illumination. In Figure 15(c), we obtain a hotspot of size $\sim 26.6 \pm 0.2 \mu\text{m}$ versus $25 \pm 1 \mu\text{m}$ for the simulated hotspot.

In this case, the simulated hotspot shows an increased FOV of $150 \mu\text{m}$ between the central hotspot and the main bright sidelobe. There are minor sidelobes whose intensities are lower than the central hotspot. In the experiment, we get considerably similar results with an increased FOV of $154 \mu\text{m}$. However, the intensity of the minor sidelobes in the experiment is not similar to that of the simulation. Still, they are almost equal or less than the central hotspot. The reason for this discrepancy can be attributed to the non-uniformity in illumination. The intensity ratio of the central spot to the main side lobes, in this case, is equal to 0.72 versus 0.87 in the experiment. Hence, we get an increased FOV with an increased Intensity ratio.

Conclusion

We have presented a novel technique for the generation and manipulation of superoscillatory hotspots. Our work brings the concept of CTF shaping to the superoscillatory research regime, which was not yet investigated before. The uniqueness of our method is that, we don't use complex mathematics for the generation of a hotspot, rather our method produces hotspots of different sizes based on the tuning of the Fourier filter mask that we introduce in the digital optimization.

In our work, we also showed the concept of increasing the FOV with a considerable intensity ratio with the hotspot to sidelobe and less loss in resolution of the generated hotspot. We hope that our technique will become an important tool in a range of applications and initiate other scientific researches using this tool.

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Author contributions

Z.Z. proposed and supervised the research. Simulations and Experiments were formulated and designed by A.S. Experiments were mainly carried out by A.S. with the support of N.S., Y.K., A.A., D.S. and M.S. Data Analysis were done by A.S.

Competing interests

The authors declare no competing interests.

Additional information

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